



Appl. No. 09/937,538

PATENT
Attorney Docket No. 81839.0102
Customer No. 26021

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michihiro MIZUNO

Serial No.: 09/937,538

Filed: September 25, 2001

For: METHOD FOR EVALUATING
CONCENTRATION OF
METALLIC IMPURITIES IN
SILICON WAFER

Art Unit: 1743

Examiner: Siefke, Samuel P.

Confirmation No. 2057

**COMMENTS ON STATEMENT OF REASONS
FOR ALLOWANCE**

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant has received a Notice of Allowance and fee due, which is dated September 15, 2004. The Notice of Allowance is accompanied by a Notice of Allowability.

On page 2 of the Notice of Allowability there is a Statement of Reasons for Allowance. In the first paragraph thereof, it is stated that the reasons for allowance can be found in the last Office Action dated "6/2/07".

Applicant wishes to note for the records that the date of the last Office Action is 6/2/2004 and not 6/2/2007.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Mail Stop Issue Fee
Commissioner for Patents
P. O. Box 1450,
Alexandria, VA 22313-1450 on

November 4, 2004

Date of Deposit

Firoozeh Vakilizadeh

Name

Firoozeh Vakilizadeh 11/4/04

Signature

Date

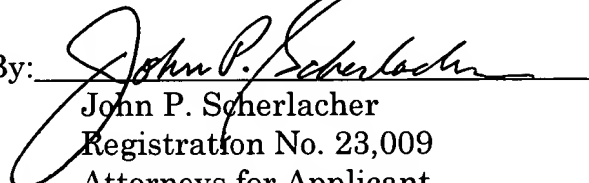
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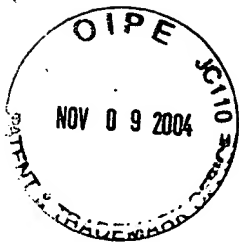
Respectfully submitted,
HOGAN & HARTSON L.L.P.

Date: November 4, 2004

By:


John P. Scherlacher
Registration No. 23,009
Attorneys for Applicant

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Date of NOA: September 15, 2004

Art Unit: 1743

TRANSMITTAL OF ISSUE FEE

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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P.O. Box 1450
Alexandria, VA 22313-1450, on
November 4, 2004
Date of Deposit
Firoozeh Vakilzadeh
Name
Firoozeh Vakilzadeh 11/4/04
Signature Date

Dear Sir:

In response to the Notice of Allowance dated September 15, 2004, enclosed
are the following:

- ☒ Form Part B - Issue Fee Transmittal and a check in the amount of
\$ 1,676.00 in payment of the Issue Fee, Publication Fee and Advance
Order for 2 patent copies (at \$3.00 per copy).
- ☒ Comments on Statement of Reasons for Allowance.

The Commissioner is hereby authorized to charge any deficiency in payment or credit any overpayment to Deposit Account No. 50-1314. A copy of this Transmittal is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: November 4, 2004

By: 

John P. Scherlacher

Registration No. 23,009

Attorney for Applicant(s)

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